



State-of-the-Art Lab-on-a-Chip Technology in Japan

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Message from the Guest Editors

Dear Colleagues,

Japanese researchers have made great contributions to Lab-on-a-Chip communities since 1990, when the concept of μ -TAS was proposed. Lab-on-a-Chip technology from Japan always had a significant impact on the mainstream of Lab-on-a-Chip and μ -TAS research. We expect that Japanese researchers will contribute continuously to this field. This Special Issue aims to provide a comprehensive overview of the state-of-the-art Lab-on-a-Chip technology in Japan. We invite research articles that will consolidate our understanding of the state-of-the-art in this area. The Special Issue will publish full research, review, and highly-rated manuscripts addressing the abovementioned topic.

Prof. Dr. Manabu Tokeshi

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Guest Editors





Editor-in-Chief

Message from the Editor-in-Chief

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